Serial No: 10/010721 Examiner: A. Psitos

Title: RELIEF DIFFRACTION GRATING BODY, AND OPTICAL PICK-UP AND OPTICAL INFORMATION APPARATUS USING SAME

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Amendments to the Specification:

Please replace the title of the invention with the following amended title:

RELIEF DIFFRACTION GRATING BODY, AND OPTICAL PICK-UP[[,]]
SEMICONDUCTOR LASER APPARATUS AND OPTICAL INFORMATION
APPARATUS USING THE SAME

Please replace the paragraph beginning on line 21 of page 7 with the following amended paragraph:

Furthermore, it is preferable that a material of the base material having the refractive index n1 is at least one material selected from the group consisting of Ta₂O₅, TiO₂, ZrO₂, Nb₂O₃, ZnS, LiNbO₃ and LiTaO₃. With the use of the above-mentioned materials, it is possible to obtain a high refractive index n1 as high as 1.9 or more.

Please replace the paragraph beginning on line 28 of page 8 with the following amended paragraph:

Furthermore, it is preferable that a material of the single base material is at least one material selected from the group consisting of Ta₂O₅, TiO₂, Nb₂O₃, ZnS, LiNbO₃ and LiTaO₃. With the use of the above-mentioned materials, it is possible to obtain a high refractive index nI as high as 1.9 or more.

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Please replace the paragraph beginning on line 26 of page 26 with the following amended paragraph:

In the above, as the material with high refractive index, the case of using Ta₂O₅ was explained. However, it is to be noted that the material is not limited to Ta₂O₅ and other materials also can be used. For example, TiO₂ (refractive index: about 2.3.) ZrO₂ (refractive index: about 1.95.), Nb₂O₃ (refractive index: about 2.3.), ZnS (refractive index: about 2.3.), LiNbO₃ (refractive index: about 2.0.), LiTaO₃ (refractive index: about 1.9 to 2.0.), and the like may be used.